

# In Situ Transmission Electron Microscopy Study of Molybdenum Oxide Contacts for Silicon Solar Cells

Haider Ali<sup>1,2</sup>, Supriya Koul<sup>1</sup>, Geoffrey Gregory<sup>1,2</sup>, James Bullock<sup>3</sup>, Ali Javey<sup>3</sup>, Akihiro Kushima<sup>1</sup>, Kristopher O. Davis<sup>1,2</sup>

1. Department of Materials Science and Engineering, University of Central Florida, Orlando, FL, USA

2. Florida Solar Energy Center, University of Central Florida, Cocoa, FL, USA

3. Department of Electrical Engineering and Computer Science, University of California, Berkeley, CA, USA

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## Abstract

In this study, a molybdenum oxide ( $\text{MoO}_x$ ) and aluminum (Al) contact structure for crystalline silicon (c-Si) solar cells was investigated using a combination of transmission line measurements (TLM) and in-situ transmission electron microscopy (TEM). Cross-sectional high-resolution TEM (HRTEM) micrographs revealed a  $\approx 2$  nm silicon oxide ( $\text{SiO}_x$ ) interlayer at c-Si/ $\text{MoO}_x$  interface in the as-deposited state, indicating that formation of  $\text{SiO}_x$  occurs during deposition of  $\text{MoO}_x$ . Moreover, oxygen diffusion takes place from  $\text{MoO}_x$  towards Al

resulting in the formation of a  $\approx 2$ -3 nm aluminum oxide ( $\text{AlO}_x$ ) interlayer at the  $\text{MoO}_x$ /Al interface. Based on the TLM measurements, the  $\text{MoO}_x$ /Al contact structure retains ohmic transport with low contact resistivity up to 200°C and can therefore be a potential candidate for hole-selective rear contacts in a *p*-type c-Si solar cell. This work further demonstrates the value of in situ TEM for studying the thermal stability of transition metal oxide-based carrier selective contacts employed in high efficiency c-Si solar cells.

## 1. Introduction

To minimize recombination losses in crystalline silicon solar cells, it is essential to obtain low recombination velocities both in the bulk as well as at the Si surface. Bulk recombination is taken care of by using a high-quality Si wafer. To minimize surface recombination, it is essential to have excellent surface passivation as well as suitable carrier-selectivity at both front and rear contacts. This can be accomplished with carrier selective contacts at both front and rear contact regions. For instance, doped hydrogenated amorphous silicon (a-Si:H) in combination with an ultra-thin a-Si:H(*i*) or  $\text{SiO}_2$  are often employed as Carrier selective contacts in silicon heterojunction (SHJ) solar cells. In such cases, a-Si:H(*n*) and a-Si:H(*p*) act as electron-selective and hole-selective contacts respectively. The role of a-Si:H(*i*) is to act as buffer layer apart from passivating the Si surface whereas  $\text{SiO}_2$  solely acts as a passivation layer.[1-9]

Recently, transition metal oxides have emerged as promising materials to be employed as Carrier selective contacts in SHJ cells. Typically, they consist of a thin (<10 nm) transition metal oxide layer used in combination with a-Si:H(*i*) or  $\text{SiO}_2$  at front and rear contact regions of Si solar cells. In some cases, the carrier-selectivity of these contacts is dependent on the valence-band and conduction-band offset between the metal oxide and Si. For instance, titanium oxide ( $\text{TiO}_2$ ) behaves as an electron-selective contact because the small conduction band offset ( $\Delta E_c = 0.05$  eV) with Si allows electrons to pass through the  $\text{TiO}_2$  layer and the large valence-band offset ( $\Delta E_v = 2.0$  eV) leads to hole blocking. Cell efficiencies up to 21.6% have been reported for *n*-type cells featuring  $\text{SiO}_2/\text{TiO}_2/\text{Al}$  rear contact.[6, 7, 10, 11]

Likewise, wide band gap and high work function sub-stoichiometric metal oxides such as molybdenum oxide ( $\text{MoO}_x$ ),

tungsten oxide ( $\text{WO}_x$ ) and vanadium oxide ( $\text{VO}_x$ ) have emerged as effective hole-selective contacts in Si solar cells. The large work function difference between Si and these  $n$ -type metal oxides induces a strong upward band bending in Si, lowering the electron concentration at the surface. The wide band gap ( $>3$  eV) of these materials results in high transparency, and they have therefore been used as hole-selective front contacts in combination with transparent conducting oxide (TCO) window layers such as hydrogenated indium oxide (I<sub>0</sub>:H) or indium tin oxide (ITO). [2, 12-16] However, a major limitation of these contact structures is that they are sensitive to low temperature annealing resulting in degradation of device performance. Although, the origin of these losses is yet to be fully understood, it appears that the poor performance is due to a reduction in the work function upon annealing and resulting loss of hole-selectivity. [17, 18]

Carrier selective contacts can also be formed using transition metal oxides in direct contact with metal such as Al. For instance,  $\text{WO}_x/\text{Al}$  has been investigated as potential hole-selective rear contact for a  $p$ -type c-Si solar cell.[19] It was further revealed that although  $\text{WO}_x/\text{Al}$  is stable up to  $400^\circ\text{C}$ , it exhibits non-ohmic behavior. [20] In the present work, a  $\text{MoO}_x/\text{Al}$  contact structure was investigated as a potential hole-selective rear contact for  $p$ -type c-Si solar cell instead of  $\text{WO}_x/\text{Al}$ . For this purpose, the thermal stability of c-Si/ $\text{MoO}_x/\text{Al}$  contact structure was investigated with the help of in-situ transmission electron microscopy (TEM). Furthermore, the contact resistivity at various annealing temperatures was measured by transmission line measurements (TLM).

## 2. Experimental

$\text{MoO}_x$  thin films ( $<10$  nm) were deposited on  $p$ -type FZ (100) c-Si wafers under vacuum by thermal evaporation wherein a powder  $\text{MoO}_3$  source was used. During the evaporation process, Si substrate remained at ambient temperature. Finally, 500 nm of Al was evaporated over  $\text{MoO}_x$ . A schematic of test structure used for TLM

measurement is shown as an inset in Figure 1.

Dark current-voltage (I-V) curves were measured for several contact pairs at different spacings at various annealing temperatures using a Keithley 2400 Sourcemeter. This data was then used to extract the contact resistivity of the  $\text{MoO}_x/\text{Al}$  contact stack. To account for current spreading occurring due to absence of an emitter, the extended TLM was used. [21] For TEM studies, cross-sectional TEM specimen was prepared by focused ion beam (FIB) milling technique using FEI 200 TEM FIB. The in-situ TEM experiments were performed with the help of FEI Tecnai F30 under operating voltage of 300 KV. Cross-sectional TEM specimen was heated in-situ using Gatan heating holder (Model 652) up to temperature of  $400^\circ\text{C}$  at a heating rate of  $50^\circ\text{C}/\text{min}$ . with annealing time of 10 min.

## 3. Results and discussion

The contact resistivity values obtained at various annealing temperatures by TLM are shown in Figure 1. It is evident that  $\text{MoO}_x/\text{Al}$  exhibits ohmic character in the as-deposited state with a low contact resistivity value of  $24 \text{ m}\Omega\cdot\text{cm}^2$ . On the other hand, cross-sectional HRTEM images revealed that 2-3 nm  $\text{SiO}_x$  interlayer is present at c-Si/ $\text{MoO}_x$  interface even in the as-deposited state (Figure 2(a)). This indicates that  $\text{SiO}_x$  interlayer was formed during thermal evaporation of  $\text{MoO}_x$  over Si substrate. This is consistent with observations reported by Sachetto *et. al.* It has been previously reported that the  $\text{SiO}_x$  interlayer is sub-stoichiometric and therefore allows conduction of charge carrier through it. [15, 16] The net effect is that the conduction of charge carriers in the  $\text{MoO}_x/\text{Al}$  contact is not adversely affected by the presence of sub-stoichiometric  $\text{SiO}_x$  interlayer.

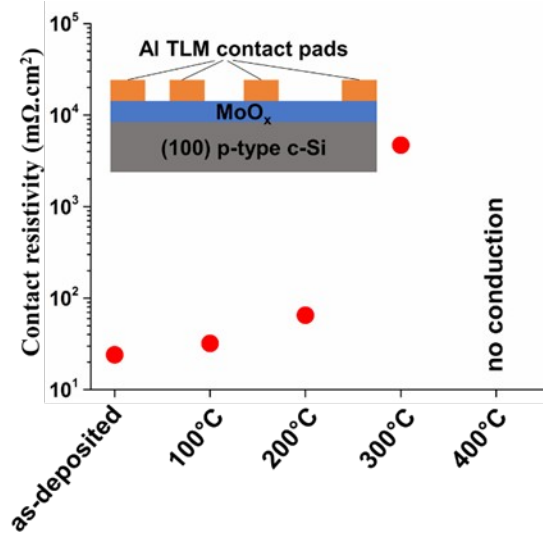


Figure 1: Contact resistivity at various annealing temperatures obtained by TLM.

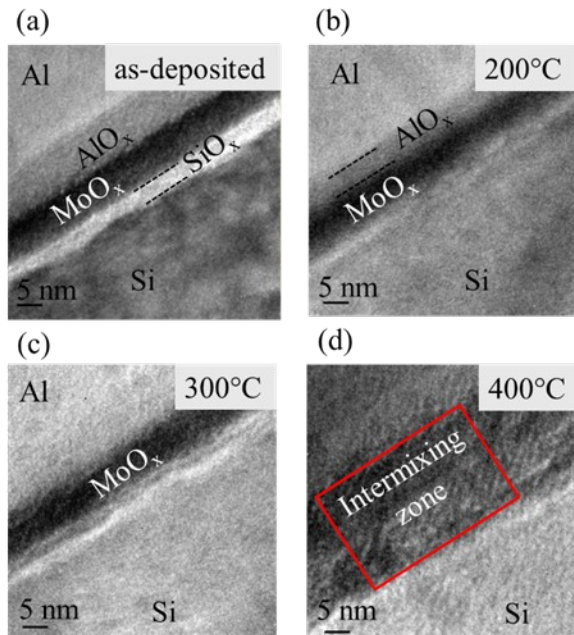


Figure 2: Cross-sectional HRTEM micrograph of  $c\text{-Si}/\text{MoO}_x/\text{Al}$  structure obtained by in-situ TEM studies: (a) as-deposited (b) 200°C (c) 300°C (d) 400°C

Moreover,  $\text{MoO}_x/\text{Al}$  retains its hole-blocking ability even in presence of  $\text{SiO}_x$  which is evident from the simulated band diagram of  $c\text{-Si}/\text{SiO}_x/\text{MoO}_x/\text{Al}$  contact structure as shown in Figure 3. This was obtained with the help of wxAMPS. [22]

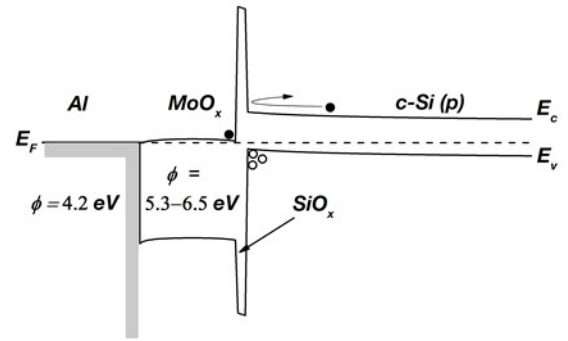


Figure 3: The energy band diagram of the  $\text{MoO}_x/\text{Al}$  contact to  $p\text{-type } c\text{-Si}$  with 2 nm of  $\text{SiO}_x$

Furthermore, HRTEM images further revealed the presence of an  $\text{AlO}_x$  interlayer at the  $\text{MoO}_x/\text{Al}$  interface in the as-deposited state (Figure 2(a)). This can be attributed to favorable thermodynamic conditions.[23] The higher oxygen affinity of Al compared to Mo is the driving force for oxygen diffusion from  $\text{MoO}_x$  towards Al resulting in the formation of  $\text{AlO}_x$  interlayer as well as creation of defect states within  $\text{MoO}_x$  layer.

When the annealing temperature is increased to 200°C,  $\text{AlO}_x$  and  $\text{MoO}_x$  layers are clearly distinguishable which indicates that no major change occurs at  $\text{MoO}_x/\text{AlO}_x$  interface. However,  $\text{SiO}_x$  layers become diffused and less obvious at 200°C (Figure 2(b) and video 2(b)). Overall, it can be inferred that  $c\text{-Si}/\text{MoO}_x/\text{Al}$  contact structure is relatively stable up to 200°C with no significant changes occurring up to 200°C. This is further supported by TLM measurements which revealed that  $\text{MoO}_x/\text{Al}$  retains its ohmic behavior when annealed to 100°C and subsequently to 200°C. Further, low contact resistivity values of 32  $\text{m}\Omega\cdot\text{cm}^2$  and 65  $\text{m}\Omega\cdot\text{cm}^2$  are obtained at 100°C and 200°C, respectively.

When annealing temperature is further increased to 300°C, significant intermixing appears to take place and the  $\text{AlO}_x$  interlayer becomes indistinguishable from the Al contact, but the  $\text{MoO}_x$  layer still appears to be intact (Figure 2(c) and video 2(c)). More importantly, a drastic increase in contact resistivity occurs at 300°C which is demonstrated by the high contact resistivity value of 4700  $\text{m}\Omega\cdot\text{cm}^2$ .

Interestingly, the MoO<sub>x</sub>/Al contact structure still retains ohmic transport.

Subsequently, at 400°C, intermixing appears to be complete which results in MoO<sub>x</sub>/Al contact structure becoming non-ohmic and no conduction is observed during TLM measurements (Figure 2(d) and video 2(d)).

Overall, the MoO<sub>x</sub>/Al contact exhibits ohmic behavior and sufficiently low contact resistivity values up to 200°C. This is in marked contrast to a-Si:H(i)/MoO<sub>x</sub>/ITO contact structure wherein a drastic increase in contact resistivity is observed upon annealing up to 200°C. [17, 18]

In a nutshell, MoO<sub>x</sub>/Al can withstand low temperature anneals and still exhibit ohmic behavior with sufficiently low contact resistivity values (65 mΩ·cm<sup>2</sup>). Therefore, the MoO<sub>x</sub>/Al contact may be potential candidate to be employed as a hole-selective rear contact for a *p*-type c-Si solar cell. The low contact resistivity of MoO<sub>x</sub>/Al up to 200°C is a significant improvement compared to WO<sub>x</sub>/Al which exhibits non-ohmic behavior even up to 400°C.[20]

#### 4. Conclusion

In summary, this work has demonstrated that the MoO<sub>x</sub>/Al contact can be a potential candidate to be employed as hole-selective rear contact for a *p*-type c-Si solar cell which can withstand annealing temperatures up to 200°C without any degradation and still retain ohmic character with sufficiently low contact resistivity. Furthermore, in situ TEM studies can be used to obtain valuable information about the thermal stability of contact structures formed by various combinations of transition metal oxides and metal contacts employed in high efficiency c-Si solar cells.

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